

1 ABSTRACT

2 Double-faced detecting devices for an electronic substrate, the detecting device have a  
3 base and two probe-detecting machines oppositely located beside the base. The base has a  
4 guiding groove and a substrate platform with a through hole rotatably and movably  
5 mounted on the base via the guiding groove. Therefore, when the electronic substrate  
6 mounts on the substrate platform, the substrate platform enables to rotate from a horizontal  
7 position to a vertical position to expose two faces of the electronic substrate to face the two  
8 probe-detecting machines for a double-faced detection of the electronic substrate in  
9 high-frequency properties. Additionally, each probe-detecting machine is mounted on a  
10 pivot base and pivoted by the pivot base to adjust the height of probe to touch the electronic  
11 substrate at the vertical position.